ASMMC.9CP1DV1C1 PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Arthur Sherman

App. No : 10/683,727

Filed: October 10, 2003

For : SEQUENTIAL CHEMICAL VAPOR

DEPOSITION

Examiner : Gambetta, Kelly M.

Art Unit : 1792

Conf No. : 1627

## AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

## Mail Stop AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## Dear Sir:

The present paper is submitted in response to the Office Action dated July 31, 2009 and is accompanied by a Declaration by Suvi Haukka under 37 C.F.R. § 1.132. Entry of the present amendments to cancel a claim and consideration of the subsequent remarks is respectfully requested.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.